

1117.68308



IFW ✓

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Application of:)
Applicant(s): Hongyong Zhang)
Serial No.: 10/664,146)
Conf. No.: 3479)
Filed: September 17, 2003)
For: CMOS-TYPE THIN FILM)
SEMICONDUCTOR DEVICE AND)
METHOD OF FABRICATING)
THE SAME (As amended))
Art Unit: 2813)
Examiner: Smoot, Stephen W.)

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

October 14, 2004

Date



Attorney for Applicant(s)
Registration No. 41,895

AMENDMENT A

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 14, 2004, please amend the above-identified Application as follows: